



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 25, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG805674441

LABORATORY GROWN DIAMOND

MARQUISE BRILLIANT

12.29 X 5.97 X 3.82 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

1.54 CARAT

D

VVS 1

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

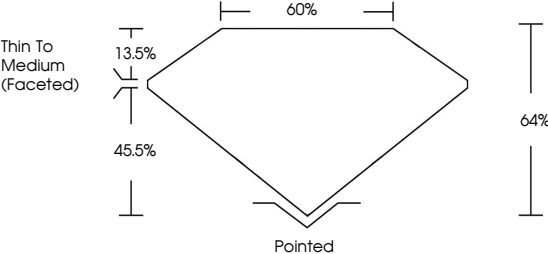
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



LG805674441

Report verification at igi.org

PROPORTIONS



Thin To Medium (Faceted)

60%

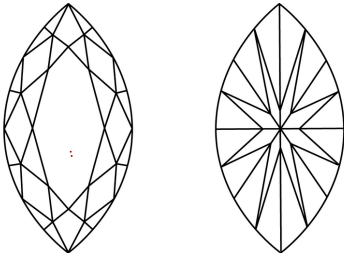
13.5%

45.5%

64%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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MARQUISE BRILLIANT

12.29 X 5.97 X 3.82 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.54 CARAT

D

VVS 1

64%

65%

Thin To Medium (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE



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